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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Hadizad et al.

Serial No.:

09/802,726

Filing Date:

March 12, 2001

Group Art Unit:

2813

Examiner:

Schillinger, Laura M

Title:

SEMICONDUCTOR COMPONENT AND METHOD OF MAKING

I HEREBY CERTIFY THAT THIS CORRESPONDENCE IS BEING DEPOSITED WITH THE UNITED STATES POSTAL SERVICE AS FIRST CLASS MAIL IN AN ENVELOPE ADDRESSED TO: COMMISSIONER OF PATENTS AND TRADEMARKS P.O. Box 1450, Alexandria, VA 22313-1450, ON: Dec. 4. 2003
Date of Deposit

Lydia McNamara

SEMICONDUCTOR COMPONENTS INDUSTRIES,

L.L.C.

Name of Person Signing Certificate

Name of Assignee

SUBMITTAL OF FORMAL DRAWINGS

Honorable Commissioner of Patents and Trademarks, P.O. Box 1450 Alexandria, VA 22313-1450

Attn: Official Draftsperson

SIR:

Enclosed are seven (7) sheets of formal drawings for the above-identified patent application in response to the Office Action mailed November 7, 2003.

Respectfully submitted,

Peyman Hadizad et al.

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